

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Ko, et al.

Docket No.: TSM03-0275

Serial No.: 10/687,377

Art Unit: 2822

Filed: October 16, 2003

Examiner: Kevin M. Picardat

For: Isolation Structure with Nitrogen-Containing Liner and Methods of Manufacture

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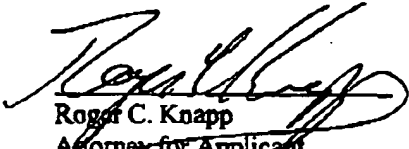
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Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450INFORMATION DISCLOSURE STATEMENT

The Applicant wishes to bring to the attention of the Patent and Trademark Office the information noted on the enclosed form PTO/SB/08A that may be considered material to the examination of the above-identified application. Pursuant to 37 CFR 1.98(a)(2)(i), as amended, copies of U.S. Patents cited are not being submitted.

This Information Disclosure Statement is submitted under 37 C.F.R. §1.97(c) together with a \$180.00 fee under 37 C.F.R. §1.17(p) after the C.F.R. §1.97(b) time period, but before final action or notice of allowance, whichever occurs first. Please charge the required fee of \$180.00 and any additional amount, or credit any overpayment to Deposit Acct. No 50-1065 of the below mentioned firm. A duplicate copy of this paper is enclosed.

Respectfully submitted,

March 3, 2005
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